

Attorney Docket No. 0756-7197

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/664,916

Filed: September 22, 2003

For: BEAM HOMOGENIZER AND LASER
IRRADIATION APPARATUS AND
METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 1722

) Examiner: R. Kunemund

) CERTIFICATE OF MAILING

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INFORMATION DISCLOSURE STATEMENT

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In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, which waives the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

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Therefore, no fee is required.

Respectfully submitted,


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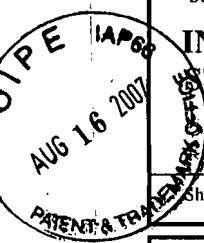
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Sheet

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Complete if Known

Application Number	10/664,916
Filing Date	September 22, 2003
First Named Inventor	Koichiro TANAKA
Group Art Unit	1722
Examiner Name	R. Kunemund
Attorney Docket Number	0756-7197

U.S. PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number ³	Kind Code ² (if known)			
		2002/0196419		Mizouchi	12/26/2002	
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		4,733,944		Fahlen et al.	03/29/1988	
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FOREIGN PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ³	Number ⁴				
		CN	1448753		10/15/2003		Full
		EP	0 747 772		12/11/1996		Abst.
		EP	0 805 368		11/05/1997		Abst.
		JP	2003-287703		10/10/2003		Full

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		KAHLERT et al., Poly-Silicon Thin Film Transistor Technology and Applications in Displays and Other Novel Technology Areas, <i>High Resolution Optics For Thin Si-Film Crystallization Using Excimer Lasers: Present Status and Future Development</i> , Vol. 5004 (2003), pp. 20-27.	

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